

Low-pressure plasma system V6-G

Efficient tabletop unit

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Easy operation due to a userfriendly touch screen panel with clear menu guidance.

The standard unit V6-G is designed as a tabletop device for industrial small series production as well as for the low-pressure plasma treatment in R&D laboratories. It can be used for the surface treatment processes cleaning and activation.

The integrated professional PLC control serves as a storage for definable processes and parameters.

System features

- Microwave coupling from the top
- Swing door
- Automatic venting of the pump line after system switch-off

Options

- Vacuum pump
- Ozone trap
- Up to two additional gas inlets
- Rotary drum for the treatment of bulk material
- Rack with shelves
- Lateral microwave coupling
- Soft start and slow vent
- Remote maintenance (VPN)/USB-Port/ Ethernet interface and controller with enhanced functionality

Technical data

Dimensions of the system (W x D x H): 640 x 710 x 710 mm Dimensions of the chamber (W x D x H): 170 x 200 x 170 mm Plasma excitation frequency: Microwave (2.45 GHz) Microwave power: 50-300 W Gas inlets with mass-flow-controller: 1 channel Power supply: 230 V, 50/60 Hz Power input (without vacuum pump): 0.5 kVA Vacuum gauge: Pirani Weight: 100 kg



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